IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicants:

Nishio, et al.

Docket No.:

49288.2800

Serial No.:

10/595,201

Examiner:

Laura M. Lee

Filed:

January 2, 2007

DICING METHOD

Group Art Unit:

3724 4462

Title:

SUBSTRATE DICING SYSTEM, SUBSTRATE MANUFACTURING

Confirmation No.:

APPARATUS, AND SUBSTRATE

AMENDMENT AND REPLY

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Commissioner:

In reply to the Office Action dated March 17, 2009, of which this Reply is within the shortened one month period for reply, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.